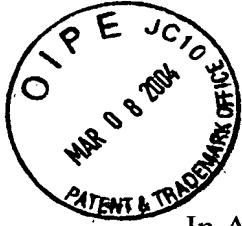


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of:	)	
Alvin D. Compaan et al.	)	Group Art Unit: Unassigned
	)	
Serial No.: 10/722,643	)	
	)	
Filed: November 26, 2003	)	Attorney Docket No. 1-24016
	)	
For: METHOD OF MAKING	)	
DIODE STRUCTURES	)	

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Honorable Sir:

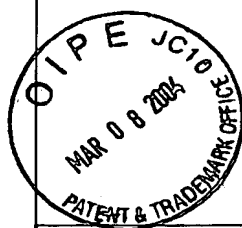
Pursuant to 37 C.F.R. 1.97(b), record is hereby made of information which the Patent Office may wish to consider in connection with its examination of the above-identified application. Copies of such information, excluding the U. S. Patents, as well as a completed PTO-1449 form, are enclosed.

Respectfully submitted,

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U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
1-24016SERIAL NO.  
10/722,643INFORMATION DISCLOSURE  
STATEMENT BY APPLICANTAPPLICANT  
Alvin D. Compaan et al.FILING DATE  
November 26, 2003GROUP  
Unassigned

## U.S. PATENT DOCUMENTS

EXAMINE R INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4,611,091	Sep. 9, 1986	Choudary et al.			
	4,612,411	Sep. 16, 1986	Wieting et al.			
	4,798,660	Jan. 17, 1989	Ermer et al.			
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	5,909,632	Jun. 1, 1999	Gessert			
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## FOREIGN PATENT DOCUMENTS

EXAMINE R INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	A.N. Tiwari, A. Romeo, D. Baetzner and H. Zogg; Progress in Photovoltaics: Research and Applications; Prog. Photovolt: Res. Appl. 2001; 9:211-215; entitled: "Flexible CdTe Solar Cells on Polymer Films"
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	J. Han et al.; 1993 American Institute of Physics; Pages 840-842; Appl. Phys. Letter. 62 (8); February 22, 1993; entitled: "Heavy p-doping of ZnTe by Molecular Beam Epitaxy using a Nitrogen Plasma Source"
DATE CONSIDERED	